

10/594895

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI, et al
Title: PLASMA PROCESSING METHOD AND METHOD FOR
MANUFACTURING AN ELECTRONIC DEVICE
Appl. No.: Unassigned
International Filing Date: 03/31/2005
371(c) Date: 09/29/2006
Examiner: Unassigned
Art Unit: Unassigned

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this document.

Remarks/Arguments begin on page 4 of this document.

Please amend the application as follows: